IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of; PE

Olle Inganas et al.

Serial No.: 09/720,259

Filed: February 2, 2001

Attorney Docket: P66218US0

Group Art Unit: 1763

Examiner: Allan W. Olsen

For: METHODS FOR PATTERNING POLYMER FILMS, AND USE OF THE METHODS

NOV 1 8 2003

TRANSMITTAL

Honorable Assistant Commissioner of Patents and Trademarks Washington, D.C. 20231

Sir:

Transmitted herewith is a Response to Restriction Requirement and Amendment in the above captioned application.

____Small Entity status of this application under 37 C.F.R. 1.9 and 1.27 has been established by a verified statement previously submitted.

____A verified Statement to establish small entity status under 37 C.F.R. 1.9 and 1.27 is enclosed.

____No additional fee is required.

The fee has been calculated as shown below:

Claims Remaining	Highest Number		Present Extra	Small Entity	Other Than A Small Entity
After	Previously			Rate Addit. (or)	Rate Addit.
Amendment	Paid For			Fee	Fee
<u>Total -</u>	20	=	0	x09 = \$	x 18 = \$
<u>Indep</u>	3	=	0	x42 = \$	x 84 = \$
First Presentation of					
Multiple Dependent Claim				x140 = \$	+280 = \$
Total Additional Fee				\$	\$

__ A check in the amount of \$____ is attached for:

XX If a Petition for Extension of Time is necessary and the Petition and/or the check is not enclosed, this will act as the Petition and applicant herewith petitions the Commissioner to extend the time for response and charge any fees necessary under 37 CFR 1.17 (a)(1)-(5) to Deposit Account No. 06-1358. The Commissioner is also authorized to charge payment of any other additional fees associated with this communication or credit any overpayment to Deposit Account No. 06-1358. A duplicate copy of this sheet is attached.

JACOBSON HOLMAN, PLLC

Dated: November 18, 2003 400 Seventh Street, N. W. Washington, D.C. 20004-2201

JLS/dmt

Jonathan L. Scherer

Req. No. 29,851



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RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement dated October 20, 2003 (paper No. 8), applicant elects, with traverse, the invention of Group II, claims 14-25, directed to a method of applying a patterned polymer film onto a surface wherein a polymer film is applied to a stamp and then portions of the polymer film are transferred from the stamp to the surface, for further prosecution on the merits. In addition, please amend the abovecaptioned application as follows: